

APPLICATION DATA SHEET

Application Information

Application Type:: Regular
Subject Matter:: Utility
Suggested Classification::
Suggested Group Art Unit::
Title:: METHOD FOR CONTROLLING GROWTH
OF A SILICON CRYSTAL TO
MINIMIZE GROWTH RATE AND
DIAMETER DEVIATIONS
Attorney Docket Number:: MEMCTP985751(2358.4)
Request for Early Publication?:: No
Request for Non-Publication?:: No
Suggested Drawing Figure::
Total Drawing Sheets:: 05
Small Entity?:: No

Applicant Information

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Italy
Status:: Full Capacity
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City of Mailing Address:: St. Peters
State or Province of Mailing
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Applicant Authority Type:: Inventor
Primary Citizenship Country:: Russia
Status:: Full Capacity